

**Notice of References Cited**

Application/Control No.

10/721,314

Applicant(s)/Patent Under  
Reexamination  
SNYDER ET AL.

Examiner

Fawaad Haider

Art Unit

3627

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,893,076	04-1999	Hafner et al.	705/28
*	B	US-2002/0099598	07-2002	Eicher et al.	705/11
*	C	US-2003/0172007	09-2003	Helmolt et al.	705/28
*	D	US-5,953,707	09-1999	Huang et al.	705/10
*	E	US-2003/0158795	08-2003	Markham et al.	705/28
*	F	US-2002/0143669	10-2002	Scheer, Robert H.	705/28
*	G	US-6,640,244	10-2003	Bowman-Amuah, Michel K.	709/207
*	H	US-7,092,929	08-2006	Dvorak et al.	705/28
*	I	US-2002/0069155	06-2002	Nafeh et al.	705/37
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.